



FORM PTO-1449	Docket Number (Optional) 006869USA	Application Number 10/659,902
INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (Use several sheets if necessary)	Applicant SOMEKH	
	Filing Date September 11, 2003	Group Art Unit 1753
7085		

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE
SHV	5	1	6	0	5	7	6	11/3/92	Robbins	216	60	
SHV	5	2	9	0	3	8	3	3/1/94	Koshimizu	156	345.25	
SHV	5	3	4	7	4	6	0	9/13/94	Gifford et al.	700	121	
SHV	5	7	2	8	2	5	3	3/17/98	Saito et al.	156	345.25	
SHV	5	8	7	1	6	5	8	2/16/99	Tao et al.	216	60	
SHV	5	9	8	0	7	6	7	11/9/99	Koshimizu et al.	216	60	
SHV	6	1	1	7	3	4	8	9/12/00	Peng et al.	216	60	
SHV	6	1	2	1	1	4	7	9/19/00	Daniel et al.	438	692	
SHV	6	1	9	0	9	2	7	2/20/01	Liu	438	8	
SHV	6	2	0	7	0	0	8	3/27/01	Kijima	216	59	
SHV	6	2	5	8	4	9	7	7/10/01	Kropp et al.	430	30	
SHV	6	2	6	5	3	1	6	7/24/01	Yoshida	438	700	
SHV	6	2	9	7	0	6	4	10/2/01	Koshimizu	438	9	
SHV	6	3	2	6	7	9	4	12/4/01	Lundquist et al.	324	678	

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation	
												YES	NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

SHV	Li, et al. US 2001/0007772 pub. 7/12/01
SHV	Radzimski, Z. J., et al. "Optical emission spectroscopy of high density metal plasma formed during magnetron sputtering." J. Vac. Sci. Tech., B 15(2), Mar/Apr 1997; pp 202-208.

EXAMINER 	DATE CONSIDERED 
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.